



503.36911CX1

14/D  
BH  
11/06/81

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. ONO, et al  
Serial No.: 09/249,292 (CPA)  
Filed: February 12, 1999  
For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR  
Group: 1746  
Examiner: A. Olsen

PRELIMINARY AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

October 31, 2001

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified CPA filed on this date and is responsive to the Office Action dated July 31, 2001.

IN THE CLAIMS:

Please add the following new claim:

--28. A method according to claim 1, wherein the on-off modulating of the rf bias voltage is effected at a cycle longer than a cycle of the rf bias voltage waveform.--

RECEIVED  
NOV 02 2001  
TC 1700

05/24/2001 11:15 AM  
01-PC-111 100-00-CH